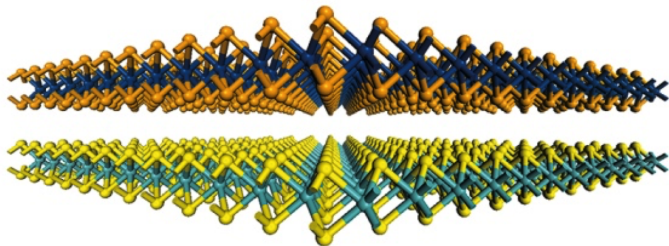


Observation of Interlayer Excitons in Monolayer MoSe₂ – WSe₂ Heterostructures on BN Substrate

Alice Huang, Rutgers University



2015 INT REU, University of Washington
Advisor: Xiaodong Xu

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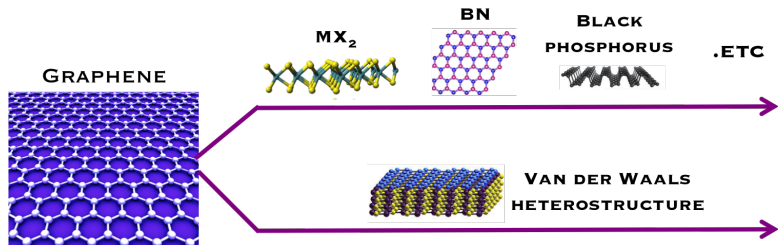
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- 2 Fabrication
- 3 Results and Discussion
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2D Materials^{1 2}

- Graphene is a vast field with more than 10,000 papers published every year → in the recent years, research has expanded to other 2D materials and van der Waals heterostructures

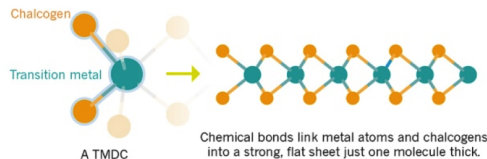


¹ Geim, A. K., et. al, Nature 499, 419-425 (2013)

² Gibney, Elizabeth, Nature 522, 7556 (2015)

2D Materials ¹ ²

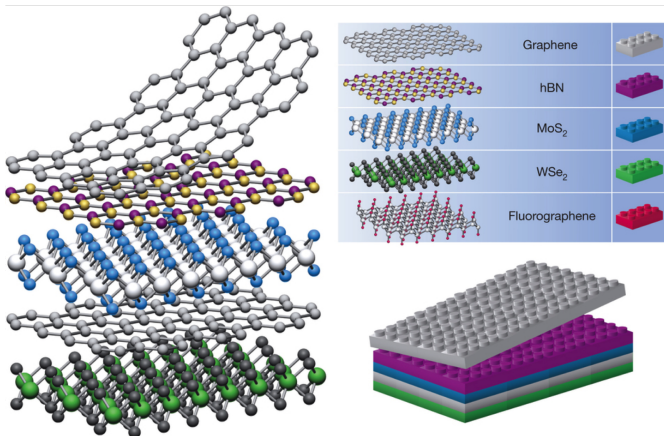
- Transition-Metal Dichalcogenide (TMDC) → chemical formula: MX₂



H																	He	
Li	Be											B	C	N	O	F	Ne	
Na	Mg											Al	Si	P	S	Cl	Ar	
K	Ca	Sc	Ti	V	Cr	Mn	Fe	Co	Ni	Cu	Zn	Ga	Ge	As	Se	Br	Kr	
Rb	Sr	Y	Zr	Nb	Mo	Tc	Ru	Rh	Pd	Ag	Cd	In	Sn	Sb	Te	I	Xe	
Cs	Ba	Ln	Hf	Ta	W	Re	Os	Ir	Pt	Au	Hg	Tl	Pb	Bi	Po	At	Rn	
Fr	Ra	An	Rf	Db	Sg	Bh	Hs	Mt	Ds	Rg								
		La	Ce	Pr	Nd	Pm	Sm	Eu	Gd	Tb	Dy	Ho	Er	Tm	Yb	Lu		
		Ac	Th	Pa	U	Np	Pu	Am	Cm	Bk	Cf	Es	Fm	Md	No	Lr		

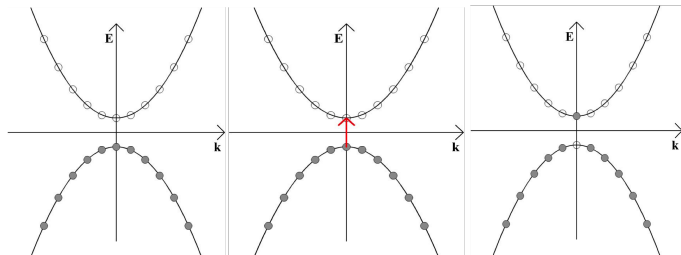
2D Materials ^{1 2}

- Building van der Waals heterostructures → Lego block metaphor



What is excitonic physics? ³ ⁴

- Absorption of a photon with energy surpassing the bandgap: (1) excites valence band electron into conduction band, (2) creates a 'hole' in the valence band where electron once was



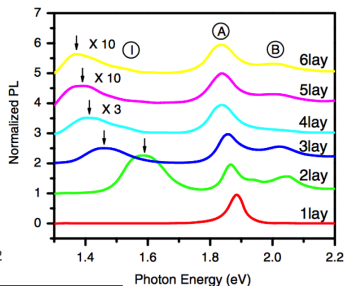
- Given sufficient Coulomb BE, the electron and hole bind together to form an **exciton**, a quasi-particle analogous to the hydrogen atom

³ Knowles, Kevin, et. al, "Introduction to Semiconductors," University of Cambridge DoITPoMS (2007)

⁴ Miller, D. A. B., "Optical Physics of Quantum Wells" (1996)

Why are monolayer MX₂'s an ideal material for exploring excitonic physics at the 2D limit? ⁵ ⁶

- Characterization of MoS₂ with (a) photoluminescence and (b) optical absorption measurements show crossover from indirect to direct bandgap at the 2D monolayer limit

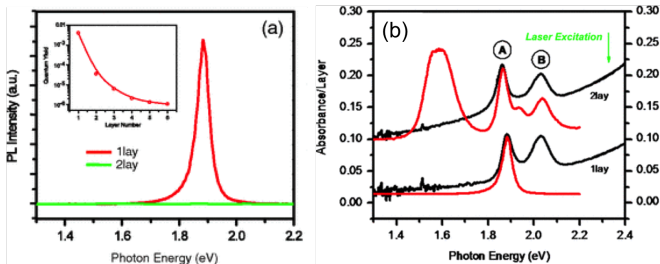


⁵ Mak, Kin Fai, et. al, Phys. Review Letters 105, 136805 (2010)

⁶ Ross, Jason S., Sanfeng Wu, et. al, Nature Communications 4, 1474 (2012)

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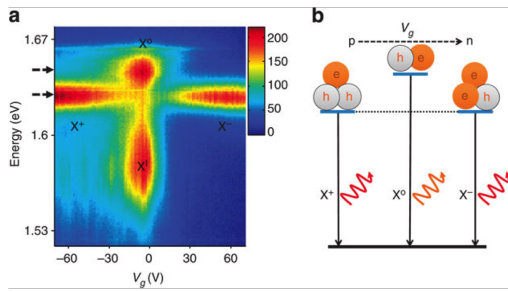


⁵ Mak, Kin Fai, et. al, Phys. Review Letters 105, 136805 (2010)

⁶ Ross, Jason S., Sanfeng Wu, et. al, Nature Communications 4, 1474 (2012)

Why are monolayer MX₂'s an ideal material for exploring excitonic physics at the 2D limit? ⁵ ⁶

- Because MX₂'s have high Coulomb BE, the neutral exciton (X^0) can bind to an additional electron or hole to become a **trion**, a charged three-body particle (X^- and X^+ respectively)
- Gate dependent PL shows the electric tunability of excitons in MoSe₂

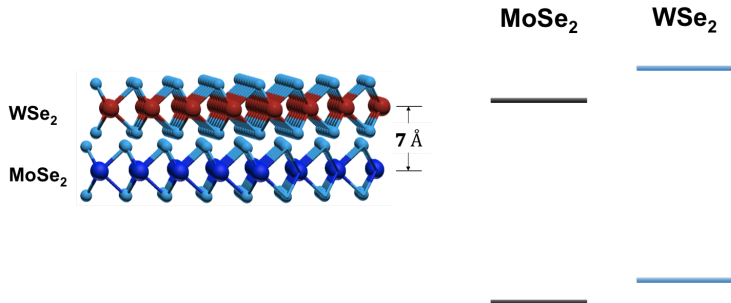


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Observation of interlayer excitons in monolayer MoSe₂ – WSe₂ heterostructures ⁷

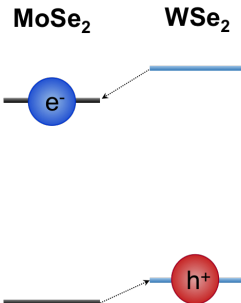
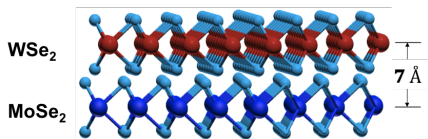
- Type II heterojunction between MoSe₂ and WSe₂



⁷ Rivera, Pasqual, et al., Nature Communications 6, 6242 (2015)

Observation of interlayer excitons in monolayer MoSe₂ – WSe₂ heterostructures ⁷

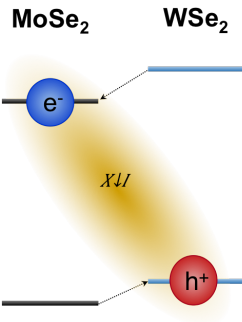
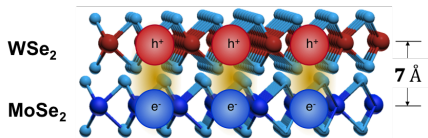
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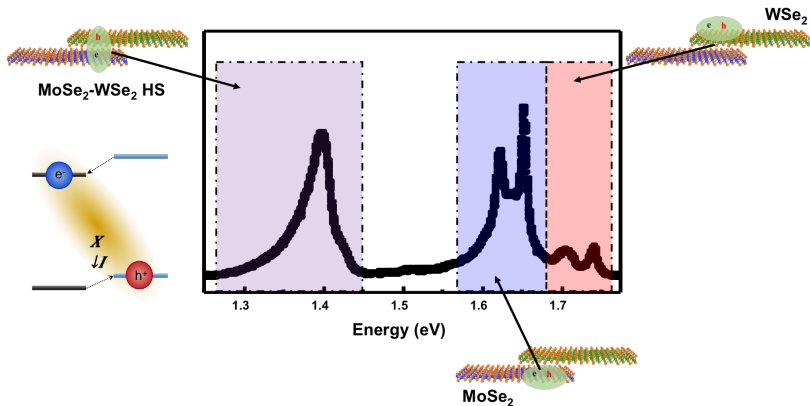
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⁷ Rivera, Pasqual, et al., Nature Communications 6, 6242 (2015)

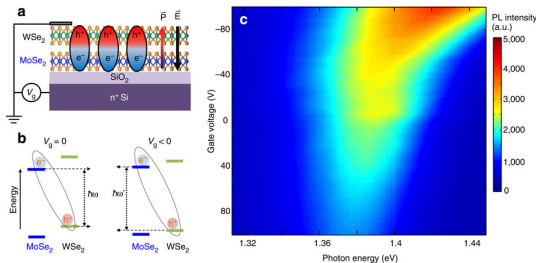
Observation of interlayer excitons in monolayer MoSe₂ – WSe₂ heterostructures ⁷

Figure 1: PL measurements reveal distinct interlayer exciton peak



Electrical control of the interlayer exciton ⁷

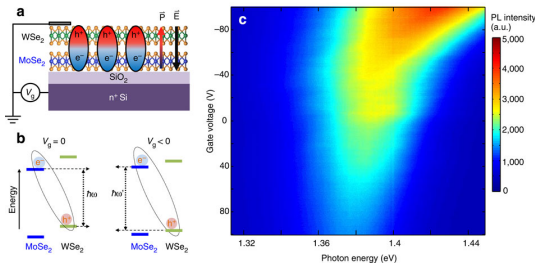
Figure 2: Gate control of the interlayer exciton and band alignment



- Expect a permanent dipole pointing from MoSe₂ to WSe₂

Electrical control of the interlayer exciton ⁷

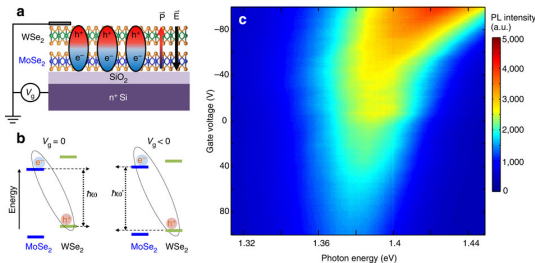
Figure 2: Gate control of the interlayer exciton and band alignment



- Expect a permanent dipole pointing from MoSe_2 to WSe_2
- However when stacking order of MoSe_2 and WSe_2 is reversed, the PL intensity with respect to applied voltage does not reverse!

Electrical control of the interlayer exciton ⁷

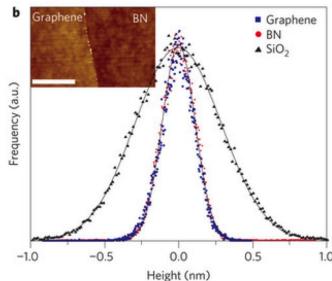
Figure 2: Gate control of the interlayer exciton and band alignment



- Expect a permanent dipole pointing from MoSe₂ to WSe₂
- However when stacking order of MoSe₂ and WSe₂ is reversed, the PL intensity with respect to applied voltage does not reverse!
- Possibly due to charge carrier doping...?

Boron Nitride substrate for ultra-flat high quality electronics^{8 9}

- h-BN is flat and isomorphous with MX₂'s



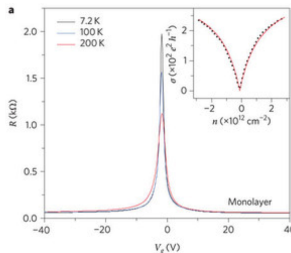
- AFM measurements show graphene is smoothed by h-BN substrate
- The height distribution for h-BN is nearly identical to that of graphene → graphene adheres to h-BN; distribution width for SiO₂ is 3 times as large

⁸Dean, CR, et al., Nature Nanotech 4, 722-726 (2010)

⁹Xue, Jiamin, et. al., Nature Materials 10, 282-285 (2011)

Boron Nitride substrate for ultra-flat high quality electronics ^{8 9}

- h-BN is inert and free of dangling bonds and surface charge traps



- For graphene on h-BN, resistivity peak as a function of backgate (otherwise the charge neutrality point) occurs at $V_g = 0 \rightarrow$ h-BN is already charge neutral without application of external voltage
- From the width of the resistivity peak, carrier inhomogeneity can be determined $\rightarrow \delta_n < 7 * 10^{10} cm^{-2}$, 3 times better than SiO₂ samples

Project Objective, Hypothesis, Questions

Objective

Fabricate and ? a $\text{MoSe}_2 - \text{WSe}_2$ heterostructure onto a BN substrate

Project Objective, Hypothesis, Questions

Objective

Fabricate and ? a $\text{MoSe}_2 - \text{WSe}_2$ heterostructure onto a BN substrate

Hypothesis

We hypothesize the BN substrate will:

- 1 smooth the heterostructure surface
- 2 reduce the heterostructure carrier charge effects

Project Objective, Hypothesis, Questions

Objective

Fabricate and ? a MoSe₂ – WSe₂ heterostructure onto a BN substrate

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We hypothesize the BN substrate will:

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Questions

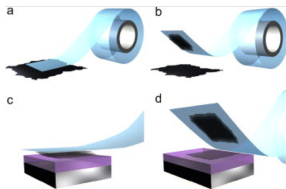
- 1 Will smoothing of the surface change the band structure and the excitonic behavior of the heterostructure?
- 2 Will reducing charge carrier effects result in behavior that is consistent with the dipole-electric field model?

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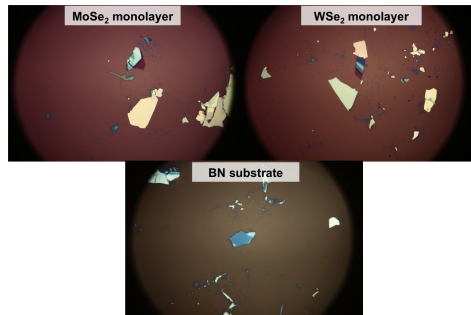
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Mechanical Exfoliation ¹⁰

1. Mechanical exfoliation of monolayers using the scotch tape method



2. Identification of monolayers under optical microscope based on color contrast against SiO₂ → visible due to thin film interference



¹⁰ Blake, P., et. al, Appl. Phys. Lett. 91, 063124 (2007)

Atomic Force Spectroscopy (AFM) ¹¹

- AFM maps the morphology of a sample which is used to determine the cleanliness of sample

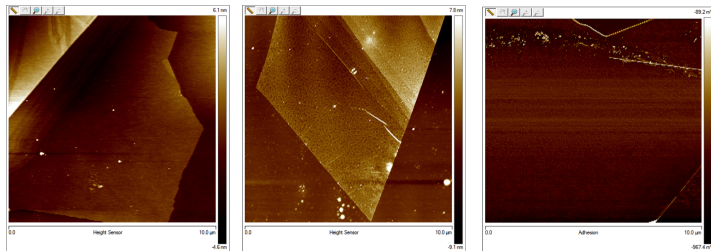
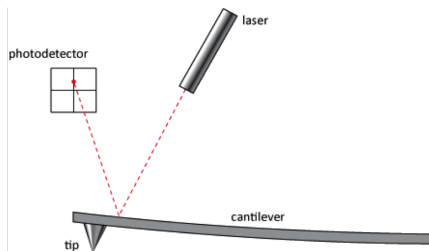


Figure 3: AFM of samples from previous slide

Atomic Force Spectroscopy (AFM) ¹¹

- AFM maps the morphology of a sample which is used to determine the cleanliness of sample
- The AFM probe oscillates at resonant frequency which changes in response to electrostatic forces → the sample morphology can be extracted from this difference in frequency



¹¹ Knowles, Kevin, et. al, "Atomic Force Spectroscopy," University of Cambridge DoITPoMS (2007)

Cleaning

- Simple experiment to determine best method for cleaning MX₂ monolayers → 10 samples characterized with AFM and/or optical microscope

Cleaning

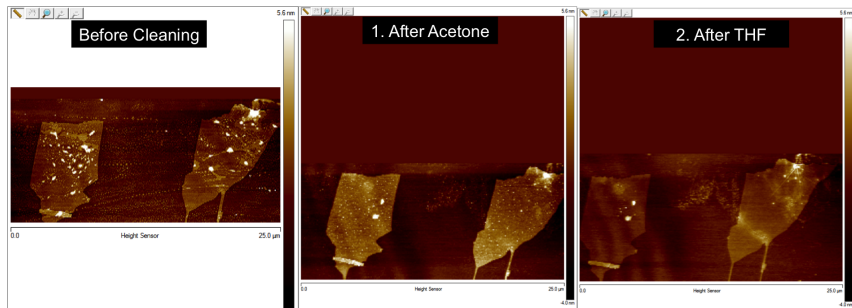
- Simple experiment to determine best method for cleaning MX₂ monolayers → 10 samples characterized with AFM and/or optical microscope
- Here is a summary of results:

Recommended Monolayer MX₂ Cleaning Procedure

- 1 15 min bath in tetrahydrofuran (THF) (BP: 66° C) at 50° C with glass cover
- 2 Immediately wash off with isopropanol and blow with nitrogen

Cleaning summary

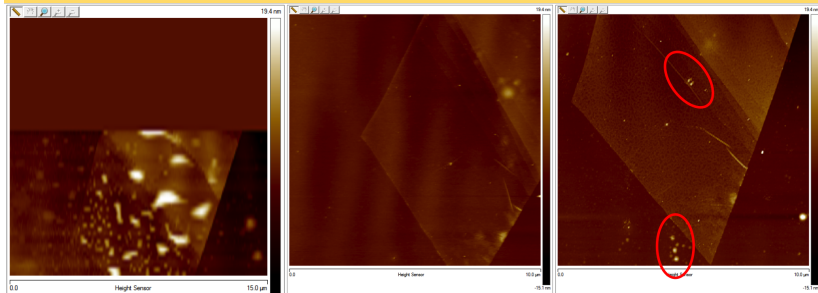
1. The AFM reveals significant improvement after a THF bath but no significant improvement after an acetone bath. In one characterization, the monolayer became dirtier after the acetone bath.



Cleaning summary

1. The AFM reveals significant improvement after a THF bath but no significant improvement after an acetone bath. In one characterization, the monolayer became dirtier after the acetone bath.

There is *more* residue after the acetone bath.



Before Cleaning

1. After THF

2. After Acetone

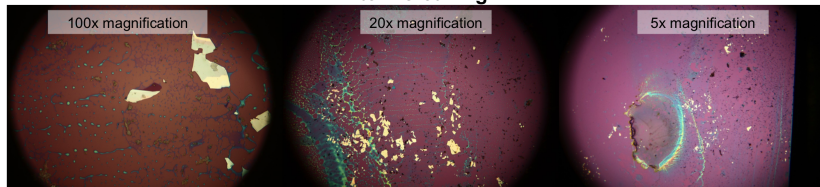
Cleaning summary

2. Immediately wash off with isopropanol after each bath → otherwise the bath will deposit the chip with dirt, rather than remove it

Before Cleaning

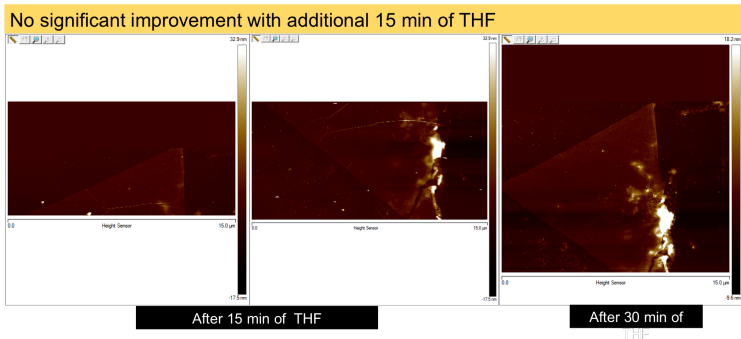


After “Cleaning”



Cleaning summary

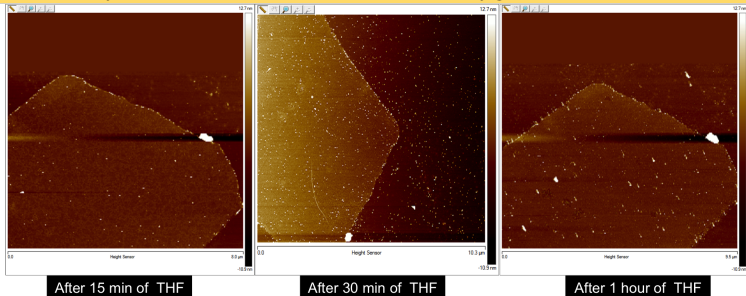
- Time of baths was reduced from 1 hour to 15 min. One characterization showed no significant improvement from 15 min of THF to 30 min of THF. Another characterization showed that the monolayer gets dirtier after more than 15 min in THF.



Cleaning summary

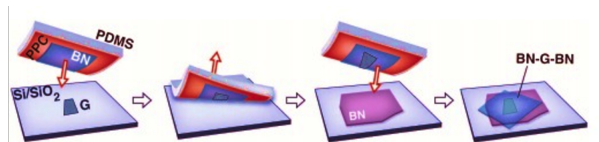
- Time of baths was reduced from 1 hour to 15 min. One characterization showed no significant improvement from 15 min of THF to 30 min of THF. Another characterization showed that the monolayer gets dirtier after more than 15 min in THF.

The monolayer is cleanest after 15 min of THF. It actually gets dirtier with increased time



Heterostructure transfer technique ¹²

- 1 Polymer stamp consisting of PDMS covered with PC film is melted upon the desired sample in the desired orientation
- 2 The set-up is subsequently cooled → the sample mount contracts, allowing the sample to lift off of the SiO₂ chip onto the stamp



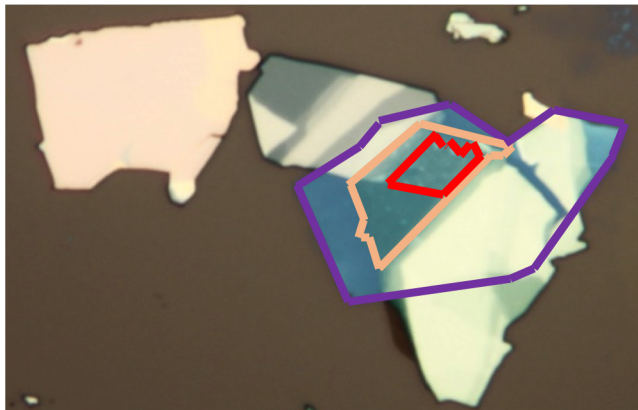
- 3 The previous two steps are repeated for the desired heterostructure stack
- 4 For the last transfer, rather than picking up the final layer, the PC layer with the heterostructure is melted onto the SiO₂ chip
- 5 The SiO₂ chip is bathed in chloroform to clean off the PC film

¹²Zomer, P. J., et. al, Appl. Phys. Lett. 105, 013101 (2014)

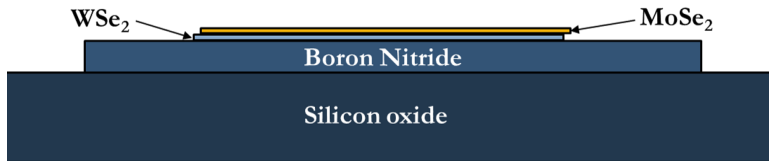
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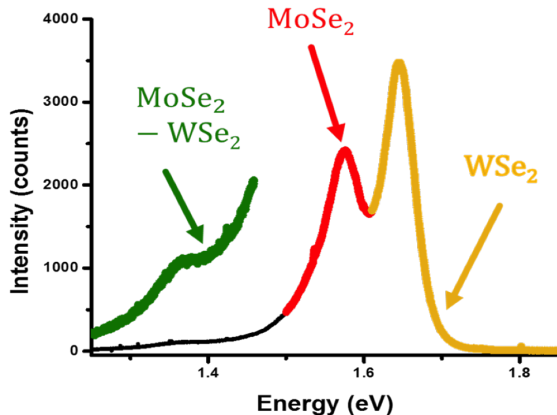
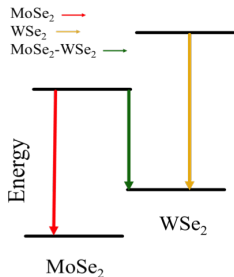
Device 1: $\text{MoSe}_2 - \text{WSe}_2 - \text{BN}$ heterostructure



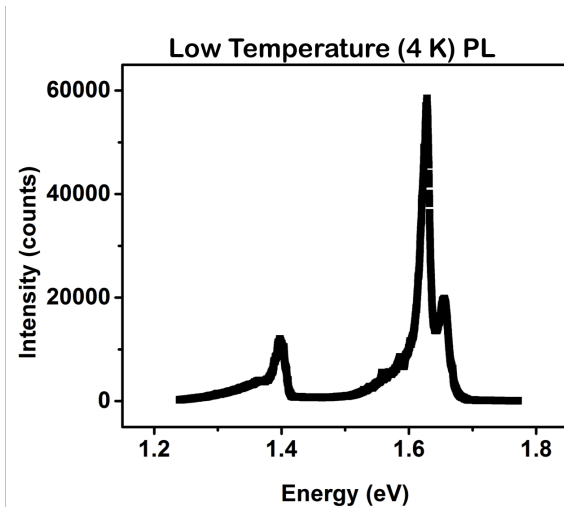
Device 1: $\text{MoSe}_2 - \text{WSe}_2 - \text{BN}$ heterostructure



Photolumuminescence Characterization



Photoluminescence Characterization



Photoluminescence Characterization

Power Dependent PL Characterization

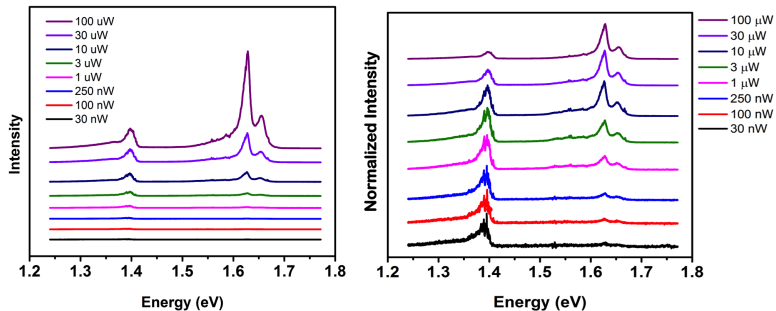
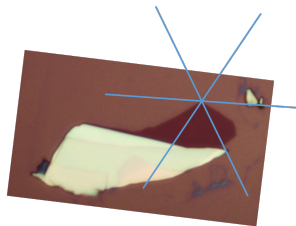
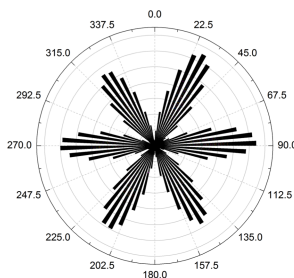


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Second Harmonic Generation (SHG) ¹³

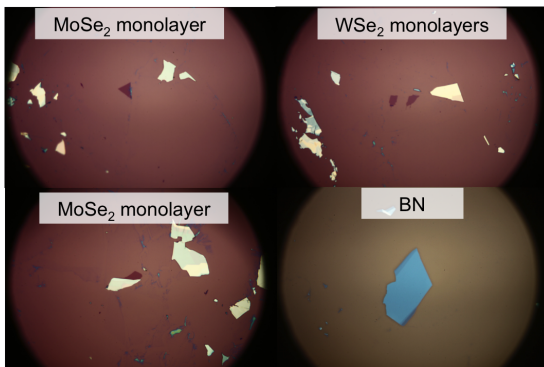
- Mediums with broken inversion symmetry are capable of generating SHG
 → non-linear optical process that doubles the frequency of input laser →
 odd layers of MX₂'s, in particular monolayers



- By sampling SHG intensity at incremental angles, one can determine the crystal axes of an MX₂ monolayer

¹³Seyler, Kyle L., et. al, Nature Nano 10, 407-411 (2015)

Device 2



- Match the crystal lattices of the the two monolayers using SHG
- Two heterostructures on one device with the same BN substrate → MoSe_2 – WSe_2 – BN and WSe_2 – MoSe_2 – BN → comparison of stacking order

Future Testing

- Spatial photoluminescence
- Electrical control of the interlayer exciton
- Power dependence and lifetime of interlayer/intralayer excitons
- Valley polarization of interlayer/intralayer excitons

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Machine Shop

The collage features technical drawings and photographs of custom metal parts. The top-left drawing is for a 'Screwdriver Index, Bench-top Stand' with dimensions 6.5 x 2.8. The top-right photo shows a set of screwdrivers with yellow handles mounted on a custom metal stand. The bottom-left photo shows a custom metal stand for an optics lab, populated with various optical components. The bottom-right drawing is for the 'Optics Stand for Au Lab' with dimensions 3.8 x 3.5 x 1.5.

Technical Drawing 1: Screwdriver Index, Bench-top Stand

PROJECT: Screwdriver Index, Bench-top Stand
 TITLE:
 APPROVED: _____ DATE: _____ CODE: _____ DWG NO: _____ REV:
 CHECKED: _____
 DRAWN: _____ SCALE: _____ METERS: _____ SHEET: _____

Technical Drawing 2: Optics Stand for Au Lab

PROJECT: Optics Stand for Au Lab
 TITLE:
 APPROVED: _____ DATE: _____ CODE: _____ DWG NO: _____ REV:
 CHECKED: _____
 DRAWN: _____ SCALE: 1:1 METERS: _____ SHEET: _____

Acknowledgements

Thank you to Xiaodong Xu for this wonderful summer lab experience.

Special thanks to Pasqual Rivera and Kyle Seyler for being outstanding mentors.

Thank you to Essance Ray, Eric Wong, Paul Nguyen, Genevieve Clark, Jason Ross, Sanfeng Wu, Harold Cai, John Schaibley, Ding Zhong, Jae Hwan Chu, Nathan Wilson, and Bevin Huang who assisted me in lab on a daily basis.

Thank you to Ron Musgrave for the machine shop lessons.

Thank you to the REU coordinators and the NSF.



Questions?